

<b>Notice of References Cited</b>	Application/Control No. 10/780,159	Applicant(s)/Patent Under Reexamination DEMEO ET AL.	
	Examiner Vivian Chen	Art Unit 1794	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,981,619	11-1999	Shikinami et al.	523/113
*	C	US-6,228,111	05-2001	Tormala et al.	623/1.38
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	K	US-			
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**NON-PATENT DOCUMENTS**

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